

**EAST Search History****EAST Search History (Interference)**

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	:0	257/686,688,692,698,774,777.ccls. and (electronic adj element and interposer and interposer adj base and post adj electrode and direct adj contact and directly adj on and (lower bottom) adj surface and (upper top) adj surface and solder (ball bump) and rewir\$3 adj (layer material film) and external adj connection adj terminal and plurality and silicon adj wafer).clm.	US- PGPUB; USPAT; UPAD	OR	ON	2010/08/14 17:09
L2	:0	(electronic adj element and interposer and interposer adj base and post adj electrode and direct adj contact and directly adj on and (lower bottom) adj surface and (upper top) adj surface and solder (ball bump) and rewir\$3 adj (layer material film) and external adj connection adj terminal and plurality and silicon adj wafer).clm.	US- PGPUB; USPAT; UPAD	OR	ON	2010/08/14 17:10

8/14/2010 5:10:42 PM

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